

## 1 CLAIMS

2 What is claimed is:

- 3 1. A method for fabricating a whispering-gallery-mode optical resonator, comprising the step of  
4 generating a spatial differential of a physical property of an optical fiber between a transverse  
5 resonator segment of the optical fiber and longitudinally adjacent transverse segments of the  
6 optical fiber, thereby enabling substantial confinement by the resonator fiber segment of a  
7 substantially resonant whispering-gallery-mode optical wave propagating around the  
8 circumference of the fiber at least partially within the resonator fiber segment.
- 9 2. A method for fabricating a whispering-gallery-mode optical resonator as recited in Claim 1,  
10 wherein the differential-generating step comprises the step of reducing the diameter of the  
11 longitudinally adjacent fiber segments relative to the diameter of the resonator fiber segment.
- 12 3. A method for fabricating a whispering-gallery-mode optical resonator as recited in Claim 2,  
13 wherein the differential-generating step comprises the steps of:  
14 providing the fiber with a mask that substantially covers the resonator fiber segment but does  
15 not cover the longitudinally adjacent fiber segments;  
16 spatially-selectively etching the optical fiber, thereby removing optical fiber material from the  
17 longitudinally adjacent fiber segments and reducing the diameter of the adjacent fiber  
18 segments relative to the diameter of the resonator fiber segment; and  
19 removing the mask from the resonator fiber segment.
- 20 4. A method for fabricating a whispering-gallery-mode optical resonator as recited in Claim 3,  
21 wherein the mask-providing step comprises spatially-selective removal of an outer fiber  
22 coating from the longitudinally adjacent fiber segments and the mask comprises a portion of  
23 the outer fiber coating remaining on the resonator fiber segment.
- 24 5. A method for fabricating a whispering-gallery-mode optical resonator as recited in Claim 4,  
25 wherein the mask-providing step comprises spatially-selective laser-machining of the outer  
26 fiber coating.
- 27 6. A method for fabricating a whispering-gallery-mode optical resonator as recited in Claim 5,  
28 further comprising the step of rotating the optical fiber during laser machining, wherein the  
29 optical fiber rotates within a capillary tube, thereby providing substantially concentric rotation  
30 during laser machining.

- 1    7. A method for fabricating a whispering-gallery-mode optical resonator as recited in Claim 5,  
2       wherein the outer fiber coating comprises a polymeric jacket and laser machining is  
3       performed with a UV-emitting excimer laser.
- 4    8. A method for fabricating a whispering-gallery-mode optical resonator as recited in Claim 5,  
5       wherein the outer fiber coating comprises a carbon coating and laser machining is performed  
6       with a pulsed laser.
- 7    9. A method for fabricating a whispering-gallery-mode optical resonator as recited in Claim 5,  
8       wherein the outer fiber coating comprises a carbon coating and laser machining is performed  
9       with a substantially continuous laser.
- 10   10. A method for fabricating a whispering-gallery-mode optical resonator as recited in Claim 5,  
11       wherein the spatially-selective etching step is performed using aqueous hydrofluoric acid.
- 12   11. A method for fabricating a whispering-gallery-mode optical resonator as recited in Claim 10,  
13       wherein the aqueous hydrofluoric acid comprises between about 5% HF and about 50% HF  
14       buffered with  $\text{NH}_4\text{F}$ .
- 15   12. A method for fabricating a whispering-gallery-mode optical resonator as recited in Claim 11,  
16       wherein the aqueous hydrofluoric acid comprises between about 7% HF and about 8% HF  
17       buffered with between about 30%  $\text{NH}_4\text{F}$  and about 40%  $\text{NH}_4\text{F}$ .
- 18   13. A method for fabricating a whispering-gallery-mode optical resonator as recited in Claim 2,  
19       wherein the differential-generating step comprises the step of removing optical fiber material  
20       from the longitudinally adjacent fiber segments by spatially-selective laser machining, thereby  
21       reducing the diameter of the adjacent fiber segments relative to the diameter of the resonator  
22       fiber segment.
- 23   14. A method for fabricating a whispering-gallery-mode optical resonator as recited in Claim 13,  
24       further comprising the step of rotating the optical fiber during laser machining, wherein the  
25       optical fiber rotates within a capillary tube, thereby providing substantially concentric rotation  
26       during laser machining.
- 27   15. A method for fabricating a whispering-gallery-mode optical resonator as recited in Claim 13,  
28       further comprising the step of removing an outer fiber coating from the resonator fiber  
29       segment and the longitudinally adjacent fiber segments prior to laser machining.
- 30   16. A method for fabricating a whispering-gallery-mode optical resonator as recited in Claim 13,  
31       further comprising the step of removing an outer fiber coating from the resonator fiber

1 segment after laser-machining, and wherein an outer fiber coating of the optical fiber on the  
2 longitudinally adjacent fiber segments is removed by laser machining.

3 17. A method for fabricating a whispering-gallery-mode optical resonator as recited in Claim 13,  
4 further comprising the step of etching the resonator fiber segment and the longitudinally  
5 adjacent fiber segments after laser machining, thereby reducing laser-machining-induced  
6 irregularities on the whispering-gallery-mode optical resonator.

7 18. A method for fabricating a whispering-gallery-mode optical resonator as recited in Claim 13,  
8 wherein laser machining is performed with a fluorine excimer laser emitting at 157 nm.

9 19. A method for fabricating a whispering-gallery-mode optical resonator as recited in Claim 2,  
10 further comprising the step of removing optical fiber material from the resonator fiber  
11 segment, thereby altering resonant frequencies of the whispering-gallery optical mode.

12 20. A method for fabricating a whispering-gallery-mode optical resonator as recited in Claim 19,  
13 wherein the diameter of the resonator fiber segment is between about 10  $\mu\text{m}$  and about 125  
14  $\mu\text{m}$ , thereby yielding a free spectral range of between about 500 GHz and about 5 THz.

15 21. A method for fabricating a whispering-gallery-mode optical resonator as recited in Claim 20,  
16 wherein the diameter of the resonator fiber segment is between about 25  $\mu\text{m}$  and about 50  
17  $\mu\text{m}$ , thereby yielding a free spectral range of between about 1 THz and about 2 THz.

18 22. A method for fabricating a whispering-gallery-mode optical resonator as recited in Claim 19,  
19 wherein the step of removing optical fiber material from the resonator fiber segment is  
20 performed by etching.

21 23. A method for fabricating a whispering-gallery-mode optical resonator as recited in Claim 22,  
22 wherein the etching step is performed using aqueous hydrofluoric acid.

23 24. A method for fabricating a whispering-gallery-mode optical resonator as recited in Claim 23,  
24 wherein the aqueous hydrofluoric comprises between about 5% HF and about 50% HF  
25 buffered with  $\text{NH}_4\text{F}$ .

26 25. A method for fabricating a whispering-gallery-mode optical resonator as recited in Claim 23,  
27 wherein the aqueous hydrofluoric acid comprises between about 7% HF and about 8% HF  
28 buffered with between about 30%  $\text{NH}_4\text{F}$  and about 40%  $\text{NH}_4\text{F}$ .

29 26. A method for fabricating a whispering-gallery-mode optical resonator as recited in Claim 19,  
30 wherein the step of removing optical fiber material from the resonator fiber segment is  
31 performed by laser machining.

- 1 27. A method for fabricating a whispering-gallery-mode optical resonator as recited in Claim 26,  
2 further comprising the step of rotating the optical fiber during laser machining, wherein the  
3 optical fiber rotates within a capillary tube, thereby providing substantially concentric rotation  
4 during laser machining.
- 5 28. A method for fabricating a whispering-gallery-mode optical resonator as recited in Claim 1,  
6 wherein the differential-generating step comprises the step of increasing the diameter of the  
7 resonator fiber segment relative to the diameter of the longitudinally adjacent fiber segments.
- 8 29. A method for fabricating a whispering-gallery-mode optical resonator as recited in Claim 28,  
9 wherein the differential-generating step comprises the steps of:  
10 providing the fiber with a mask that substantially covers the longitudinally adjacent fiber  
11 segments but does not cover the resonator fiber segment;  
12 spatially-selectively depositing dielectric material on the resonator fiber segment of the  
13 optical fiber, thereby increasing the diameter of the resonator fiber segment relative to  
14 the diameter of the adjacent fiber segments; and  
15 removing the mask from the adjacent fiber segments.
- 16 30. A method for fabricating a whispering-gallery-mode optical resonator as recited in Claim 29,  
17 wherein the mask-providing step comprises spatially-selective removal of an outer fiber  
18 coating from the resonator fiber segment and the mask comprises portions of the outer fiber  
19 coating remaining on the adjacent fiber segments.
- 20 31. A method for fabricating a whispering-gallery-mode optical resonator as recited in Claim 30,  
21 wherein the mask-providing step comprises spatially-selective laser-machining of the outer  
22 fiber coating.
- 23 32. A method for fabricating a whispering-gallery-mode optical resonator as recited in Claim 31,  
24 further comprising the step of rotating the optical fiber during laser machining, wherein the  
25 optical fiber rotates within a capillary tube, thereby providing substantially concentric rotation  
26 during laser machining.
- 27 33. A method for fabricating a whispering-gallery-mode optical resonator as recited in Claim 31,  
28 wherein the outer fiber coating comprises a polymeric jacket and laser machining is  
29 performed with a UV-emitting excimer laser.
- 30 34. A method for fabricating a whispering-gallery-mode optical resonator as recited in Claim 29,  
31 further comprising the step of rotating the optical fiber during the depositing step, wherein

1 the optical fiber rotates within a capillary tube, thereby providing substantially concentric  
2 rotation during the depositing step.

3 35. A method for fabricating a whispering-gallery-mode optical resonator as recited in Claim 29,  
4 wherein the material deposited enables modification of optical properties of the whispering-  
5 gallery-mode resonator.

6 36. A method for fabricating a whispering-gallery-mode optical resonator as recited in Claim 35,  
7 wherein the material deposited enables controlled modulation of optical loss of the  
8 whispering-gallery-mode resonator.

9 37. A method for fabricating a whispering-gallery-mode optical resonator as recited in Claim 35,  
10 wherein the material deposited enables controlled modulation of optical coupling to the  
11 whispering-gallery-mode resonator.

12 38. A method for fabricating a whispering-gallery-mode optical resonator as recited in Claim 35,  
13 wherein the material deposited enables controlled modulation of a resonant frequency of the  
14 whispering-gallery-mode resonator.

15 39. A method for fabricating a whispering-gallery-mode optical resonator as recited in Claim 35,  
16 wherein the material deposited is an electro-optic material.

17 40. A method for fabricating a whispering-gallery-mode optical resonator as recited in Claim 35,  
18 wherein the material deposited is a doped material.

19 41. A method for fabricating a whispering-gallery-mode optical resonator as recited in Claim 35,  
20 wherein the material deposited is an electro-absorptive material.

21 42. A method for fabricating a whispering-gallery-mode optical resonator as recited in Claim 35,  
22 wherein the material deposited is a non-linear optical material.

23 43. A method for fabricating a whispering-gallery-mode optical resonator as recited in Claim 35,  
24 wherein the material deposited is a semiconductor material.

25 44. A method for fabricating a whispering-gallery-mode optical resonator as recited in Claim 28,  
26 further comprising the step of removing material from the resonator fiber segment, thereby  
27 altering resonant frequencies of the whispering-gallery optical mode.

28 45. A method for fabricating a whispering-gallery-mode optical resonator as recited in Claim 44,  
29 wherein the diameter of the resonator fiber segment is between about 10  $\mu\text{m}$  and about 125  
30  $\mu\text{m}$ , thereby yielding a free spectral range of between about 500 GHz and about 5 THz.

- 1 46. A method for fabricating a whispering-gallery-mode optical resonator as recited in Claim 45,  
2 wherein the diameter of the resonator fiber segment is between about 25  $\mu\text{m}$  and about 50  
3  $\mu\text{m}$ , thereby yielding a free spectral range of between about 1 THz and about 2 THz.
- 4 47. A method for fabricating a whispering-gallery-mode optical resonator as recited in Claim 44,  
5 wherein the step of removing material from the resonator fiber segment is performed by  
6 etching.
- 7 48. A method for fabricating a whispering-gallery-mode optical resonator as recited in Claim 47,  
8 wherein the etching step is performed using aqueous hydrofluoric acid.
- 9 49. A method for fabricating a whispering-gallery-mode optical resonator as recited in Claim 48,  
10 wherein the aqueous hydrofluoric acid comprises between about 5% HF and about 50% HF  
11 buffered with  $\text{NH}_4\text{F}$ .
- 12 50. A method for fabricating a whispering-gallery-mode optical resonator as recited in Claim 48,  
13 wherein the aqueous hydrofluoric acid comprises between about 7% HF and about 8% HF  
14 buffered with between about 30%  $\text{NH}_4\text{F}$  and about 40%  $\text{NH}_4\text{F}$ .
- 15 51. A method for fabricating a whispering-gallery-mode optical resonator as recited in Claim 44,  
16 wherein the step of removing optical fiber material from the resonator fiber segment is  
17 performed by laser machining.
- 18 52. A method for fabricating a whispering-gallery-mode optical resonator as recited in Claim 51,  
19 further comprising the step of rotating the optical fiber during laser machining, wherein the  
20 optical fiber rotates within a capillary tube, thereby providing substantially concentric rotation  
21 during laser machining.
- 22 53. A method for fabricating a whispering-gallery-mode optical resonator as recited in Claim 1,  
23 wherein the differential-generating step comprises the step of increasing the refractive index  
24 of at least a portion of the resonator fiber segment relative to the refractive index of the  
25 longitudinally adjacent fiber segments.
- 26 54. A method for fabricating a whispering-gallery-mode optical resonator as recited in Claim 53,  
27 wherein the optical fiber is a UV-sensitive optical fiber and the differential-generating step  
28 comprises the step of spatially-selectively irradiating the resonator fiber segment with UV  
29 radiation, thereby increasing the refractive index of at least a portion of the resonator fiber  
30 segment by densification of the resonator fiber segment.

- 1 55. A method for fabricating a whispering-gallery-mode optical resonator as recited in Claim 54,  
2 wherein the UV-sensitive optical fiber is a germano-silicate optical fiber.
- 3 56. A method for fabricating a whispering-gallery-mode optical resonator as recited in Claim 54,  
4 further comprising the step of rotating the optical fiber during irradiating, wherein the optical  
5 fiber rotates within a capillary tube, thereby providing substantially concentric rotation during  
6 irradiating.
- 7 57. A method for fabricating a whispering-gallery-mode optical resonator as recited in Claim 54,  
8 wherein the optical fiber is irradiated using a UV-emitting excimer laser.
- 9 58. A method for fabricating a whispering-gallery-mode optical resonator as recited in Claim 54,  
10 further comprising the step of hydrogen-loading the optical fiber prior to irradiating, thereby  
11 enhancing UV-sensitivity of the optical fiber.
- 12 59. A method for fabricating a whispering-gallery-mode optical resonator as recited in Claim 54,  
13 further comprising the step of removing, prior to the irradiating step, cladding from a  
14 germano-silicate core of a multi-mode optical fiber, thereby providing the germano-silicate  
15 optical fiber for the irradiating step.
- 16 60. A method for fabricating a whispering-gallery-mode optical resonator as recited in Claim 59,  
17 wherein the cladding is removed by laser machining.
- 18 61. A method for fabricating a whispering-gallery-mode optical resonator as recited in Claim 59,  
19 wherein the cladding is removed by etching.
- 20 62. A method for fabricating a whispering-gallery-mode optical resonator as recited in Claim 53,  
21 wherein the differential-generating step comprises the steps of:  
22 providing the fiber with a mask that substantially covers the longitudinally adjacent fiber  
23 segments but does not cover the resonator fiber segment;  
24 spatially-selectively doping the resonator fiber segment of the optical fiber with a doping  
25 material, thereby increasing the refractive index of the resonator fiber segment relative to  
26 the diameter of the adjacent fiber segments; and  
27 removing the mask from the adjacent fiber segments.
- 28 63. A method for fabricating a whispering-gallery-mode optical resonator as recited in Claim 62,  
29 wherein the mask-providing step comprises spatially-selective removal of an outer fiber  
30 coating from the resonator fiber segment and the mask comprises portions of the outer fiber  
31 coating remaining on the adjacent fiber segments.

- 1 64. A method for fabricating a whispering-gallery-mode optical resonator as recited in Claim 63,  
2 wherein the mask-providing step comprises spatially-selective laser-machining of the outer  
3 fiber coating.
- 4 65. A method for fabricating a whispering-gallery-mode optical resonator as recited in Claim 64,  
5 further comprising the step of rotating the optical fiber during laser machining, wherein the  
6 optical fiber rotates within a capillary tube, thereby providing substantially concentric rotation  
7 during laser machining.
- 8 66. A method for fabricating a whispering-gallery-mode optical resonator as recited in Claim 64,  
9 wherein the outer fiber coating comprises a polymeric jacket and laser machining is  
10 performed with a UV-emitting excimer laser.
- 11 67. A method for fabricating a whispering-gallery-mode optical resonator as recited in Claim 62,  
12 wherein the mask-providing step comprises the steps of:  
13 spatially-selectively removing an outer fiber coating from adjacent fiber segments;  
14 spatially-selectively depositing the mask on the adjacent fiber segments; and  
15 removing the outer fiber coating from the resonator fiber segment.
- 16 68. A method for fabricating a whispering-gallery-mode optical resonator as recited in Claim 67,  
17 wherein the outer fiber coating is removed from the adjacent fiber segments by laser  
18 machining.
- 19 69. A method for fabricating a whispering-gallery-mode optical resonator as recited in Claim 68,  
20 further comprising the step of rotating the optical fiber during laser machining, wherein the  
21 optical fiber rotates within a capillary tube, thereby providing substantially concentric rotation  
22 during laser machining.
- 23 70. A method for fabricating a whispering-gallery-mode optical resonator as recited in Claim 68,  
24 wherein the outer fiber coating comprises a polymeric jacket and laser machining is  
25 performed with a UV-emitting excimer laser.
- 26 71. A method for fabricating a whispering-gallery-mode optical resonator as recited in Claim 67,  
27 wherein the mask is a dielectric material.
- 28 72. A method for fabricating a whispering-gallery-mode optical resonator as recited in Claim 67,  
29 wherein the mask is a metal.
- 30 73. A method for fabricating a whispering-gallery-mode optical resonator as recited in Claim 62,  
31 further comprising the step of rotating the optical fiber during the doping step, wherein the



1 optical fiber rotates within a capillary tube, thereby providing substantially concentric rotation  
2 during the doping step.

3 74. A method for fabricating a whispering-gallery-mode optical resonator as recited in Claim 62,  
4 wherein the doping material is germanium, titanium, boron, aluminum, phosphorus, erbium,  
5 ytterbium, praseodymium, thulium, holmium, neodymium, or other rare earth element.

6 75. A method for fabricating a whispering-gallery-mode optical resonator as recited in Claim 62,  
7 wherein doping step comprises allowing the doping material to diffuse into the resonator fiber  
8 segment.

9 76. A method for fabricating a whispering-gallery-mode optical resonator as recited in Claim 62,  
10 wherein the doping step comprises inserting the doping material into the resonator fiber  
11 segment by ion implantation.

12 77. A method for fabricating a whispering-gallery-mode optical resonator as recited in Claim 62,  
13 wherein the doping material enables modification of optical properties of the whispering-  
14 gallery-mode resonator.

15 78. A method for fabricating a whispering-gallery-mode optical resonator as recited in Claim 77,  
16 wherein the doping material enables controlled modulation of optical loss of the whispering-  
17 gallery-mode resonator.

18 79. A method for fabricating a whispering-gallery-mode optical resonator as recited in Claim 77,  
19 wherein the doping material enables controlled modulation of optical coupling to the  
20 whispering-gallery-mode resonator.

21 80. A method for fabricating a whispering-gallery-mode optical resonator as recited in Claim 77,  
22 wherein the doping material enables controlled modulation of a resonant frequency of the  
23 whispering-gallery-mode resonator.

24 81. A method for fabricating a whispering-gallery-mode optical resonator as recited in Claim 77,  
25 wherein the doping material is an electro-optic material.

26 82. A method for fabricating a whispering-gallery-mode optical resonator as recited in Claim 77,  
27 wherein the doping material is an electro-absorptive material.

28 83. A method for fabricating a whispering-gallery-mode optical resonator as recited in Claim 77,  
29 wherein the doping material is a non-linear optical material.

30 84. A method for fabricating a whispering-gallery-mode optical resonator as recited in Claim 77,  
31 wherein the doping material is a semiconductor material.

- 1 85. A method for fabricating a whispering-gallery-mode optical resonator as recited in Claim 53,  
2 further comprising the step of removing material from the resonator fiber segment, thereby  
3 altering resonant frequencies of the whispering-gallery optical mode.
- 4 86. A method for fabricating a whispering-gallery-mode optical resonator as recited in Claim 85,  
5 wherein the diameter of the resonator fiber segment is between about 10  $\mu\text{m}$  and about 125  
6  $\mu\text{m}$ , thereby yielding a free spectral range of between about 500 GHz and about 5 THz.
- 7 87. A method for fabricating a whispering-gallery-mode optical resonator as recited in Claim 86,  
8 wherein the diameter of the resonator fiber segment is between about 25  $\mu\text{m}$  and about 50  
9  $\mu\text{m}$ , thereby yielding a free spectral range of between about 1 THz and about 2 THz.
- 10 88. A method for fabricating a whispering-gallery-mode optical resonator as recited in Claim 85,  
11 wherein the step of removing material from the resonator fiber segment is performed by  
12 etching.
- 13 89. A method for fabricating a whispering-gallery-mode optical resonator as recited in Claim 88,  
14 wherein the etching step is performed using aqueous hydrofluoric acid.
- 15 90. A method for fabricating a whispering-gallery-mode optical resonator as recited in Claim 89,  
16 wherein the aqueous hydrofluoric acid comprises between about 5% HF and about 50% HF  
17 buffered with  $\text{NH}_4\text{F}$ .
- 18 91. A method for fabricating a whispering-gallery-mode optical resonator as recited in Claim 89,  
19 wherein the aqueous hydrofluoric acid comprises between about 7% HF and about 8% HF  
20 buffered with between about 30%  $\text{NH}_4\text{F}$  and about 40%  $\text{NH}_4\text{F}$ .
- 21 92. A method for fabricating a whispering-gallery-mode optical resonator as recited in Claim 85,  
22 wherein the step of removing optical fiber material from the resonator fiber segment is  
23 performed by laser machining.
- 24 93. A method for fabricating a whispering-gallery-mode optical resonator as recited in Claim 92,  
25 further comprising the step of rotating the optical fiber during laser machining, wherein the  
26 optical fiber rotates within a capillary tube, thereby providing substantially concentric rotation  
27 during laser machining.
- 28 94. A method for fabricating a whispering-gallery-mode optical resonator as recited in Claim 1,  
29 further comprising the step of providing, on at least one of the adjacent fiber segments, an  
30 alignment structure for enabling reproducible optical coupling of the resonator fiber segment

1 with respect to a second optical fiber when the whispering-gallery-mode optical resonator  
2 and the second optical fiber are positioned on an alignment device.

3 95. A method for fabricating a whispering-gallery-mode optical resonator as recited in Claim 94,  
4 wherein the alignment structure comprises a substantially circumferential groove.

5 96. A method for fabricating a whispering-gallery-mode optical resonator as recited in Claim 94,  
6 wherein the alignment structure comprises a substantially annular circumferential flange.

7 97. A method for fabricating a whispering-gallery-mode optical resonator as recited in Claim 94,  
8 wherein the alignment-structure-providing step comprises the step of spatially-selectively  
9 removing optical fiber material from a first portion of the adjacent fiber segment.

10 98. A method for fabricating a whispering-gallery-mode optical resonator as recited in Claim 97,  
11 wherein the material-removing step comprises the steps of:  
12 providing a remaining portion of the adjacent fiber segment with a mask;  
13 spatially-selectively etching the first portion of the adjacent fiber segment; and  
14 removing the mask.

15 99. A method for fabricating a whispering-gallery-mode optical resonator as recited in Claim 98,  
16 wherein the mask-providing step comprises spatially-selective removal of an outer fiber  
17 coating from the first portion of the adjacent fiber segment and the mask comprises a  
18 remaining portion of the outer fiber coating on the remaining portion of the adjacent fiber  
19 segment.

20 100. A method for fabricating a whispering-gallery-mode optical resonator as recited in Claim 99,  
21 wherein the mask-providing step comprises spatially-selective laser-machining of the outer  
22 fiber coating.

23 101. A method for fabricating a whispering-gallery-mode optical resonator as recited in Claim  
24 100, further comprising the step of rotating the optical fiber during laser machining, wherein  
25 the optical fiber rotates within a capillary tube, thereby providing substantially concentric  
26 rotation during laser machining.

27 102. A method for fabricating a whispering-gallery-mode optical resonator as recited in Claim  
28 100, wherein the outer fiber coating comprises a polymeric jacket and laser machining is  
29 performed with a UV-emitting excimer laser.

- 1 103. A method for fabricating a whispering-gallery-mode optical resonator as recited in Claim  
2 100, wherein the outer fiber coating comprises a carbon coating and laser machining is  
3 performed with a pulsed laser.
- 4 104. A method for fabricating a whispering-gallery-mode optical resonator as recited in Claim  
5 100, wherein the outer fiber coating comprises a carbon coating and laser machining is  
6 performed with a substantially continuous laser.
- 7 105. A method for fabricating a whispering-gallery-mode optical resonator as recited in Claim  
8 100, wherein the spatially-selective etching step is performed using aqueous hydrofluoric  
9 acid.
- 10 106. A method for fabricating a whispering-gallery-mode optical resonator as recited in Claim  
11 105, wherein the aqueous hydrofluoric acid comprises between about 5% HF and about 50%  
12 HF buffered with  $\text{NH}_4\text{F}$ .
- 13 107. A method for fabricating a whispering-gallery-mode optical resonator as recited in Claim  
14 105, wherein the aqueous hydrofluoric acid comprises between about 7% HF and about 8%  
15 HF buffered with between about 30%  $\text{NH}_4\text{F}$  and about 40%  $\text{NH}_4\text{F}$ .
- 16 108. A method for fabricating a whispering-gallery-mode optical resonator as recited in Claim 97,  
17 wherein the material-removing step is performed by laser machining.
- 18 109. A method for fabricating a whispering-gallery-mode optical resonator as recited in Claim  
19 108, further comprising the step of rotating the optical fiber during laser machining, wherein  
20 the optical fiber rotates within a capillary tube, thereby providing substantially concentric  
21 rotation during laser machining.
- 22 110. A method for fabricating a whispering-gallery-mode optical resonator as recited in Claim  
23 108, further comprising the step of removing an outer fiber coating from the longitudinally  
24 adjacent fiber segment prior to laser machining.
- 25 111. A method for fabricating a whispering-gallery-mode optical resonator as recited in Claim  
26 108, further comprising the step of removing an outer fiber coating from a remaining portion  
27 of the adjacent fiber segment after laser-machining, and wherein the outer fiber coating on the  
28 first portion of the adjacent fiber segment is removed by laser machining.
- 29 112. A method for fabricating a whispering-gallery-mode optical resonator as recited in Claim  
30 108, wherein laser machining is performed with a fluorine excimer laser emitting at 157 nm.

1 113. A method for fabricating a whispering-gallery-mode optical resonator as recited in Claim 94,  
2 wherein the alignment-structure-providing step comprises the step of spatially-selectively  
3 depositing structural material onto a first portion of the adjacent fiber segment.

4 114. A method for fabricating a whispering-gallery-mode optical resonator as recited in Claim  
5 113, wherein the material-depositing step comprises the steps of:  
6 providing a remaining portion of the adjacent fiber segment with a mask prior to depositing  
7 the structural material; and  
8 removing the mask after depositing the structural material.

9 115. A method for fabricating a whispering-gallery-mode optical resonator as recited in Claim  
10 114, wherein the mask-providing step comprises spatially-selective removal of an outer fiber  
11 coating from the first portion of the adjacent fiber segment and the mask comprises a portion  
12 of the outer fiber coating remaining on the remaining portion of the adjacent fiber segment.

13 116. A method for fabricating a whispering-gallery-mode optical resonator as recited in Claim  
14 115, wherein the mask-providing step comprises spatially-selective laser-machining of the  
15 outer fiber coating.

16 117. A method for fabricating a whispering-gallery-mode optical resonator as recited in Claim  
17 116, further comprising the step of rotating the optical fiber during laser machining, wherein  
18 the optical fiber rotates within a capillary tube, thereby providing substantially concentric  
19 rotation during laser machining.

20 118. A method for fabricating a whispering-gallery-mode optical resonator as recited in Claim  
21 116, wherein the outer fiber coating comprises a polymeric jacket and laser machining is  
22 performed with a UV-emitting excimer laser.

23 119. A method for fabricating a whispering-gallery-mode optical resonator as recited in Claim  
24 115, further comprising the step of rotating the optical fiber during the depositing step,  
25 wherein the optical fiber rotates within a capillary tube, thereby providing substantially  
26 concentric rotation during the depositing step.

27 120. A method for fabricating a whispering-gallery-mode optical resonator as recited in Claim 1,  
28 further comprising the step of providing a modulator for the optical resonator, the modulator  
29 being provided on at least one of the resonator fiber segment and the adjacent fiber segments.

- 1 121. A method for fabricating a whispering-gallery-mode optical resonator as recited in Claim  
2 120, wherein the modulator-providing step comprises the step of depositing a modulator  
3 material on at least a portion of the circumference of the resonator fiber segment.
- 4 122. A method for fabricating a whispering-gallery-mode optical resonator as recited in Claim  
5 121, wherein the modulator material enables modification of optical properties of the  
6 whispering-gallery-mode resonator.
- 7 123. A method for fabricating a whispering-gallery-mode optical resonator as recited in Claim  
8 121, wherein the modulator material enables controlled modulation of optical loss of the  
9 whispering-gallery-mode resonator.
- 10 124. A method for fabricating a whispering-gallery-mode optical resonator as recited in Claim  
11 121, wherein the modulator material enables controlled modulation of optical coupling to the  
12 whispering-gallery-mode resonator.
- 13 125. A method for fabricating a whispering-gallery-mode optical resonator as recited in Claim  
14 121, wherein the modulator material enables controlled modulation of a resonant frequency  
15 of the whispering-gallery-mode resonator.
- 16 126. A method for fabricating a whispering-gallery-mode optical resonator as recited in Claim  
17 121, wherein the modulator material is an electro-optic material.
- 18 127. A method for fabricating a whispering-gallery-mode optical resonator as recited in Claim  
19 121, wherein the modulator material is an electro-absorptive material.
- 20 128. A method for fabricating a whispering-gallery-mode optical resonator as recited in Claim  
21 121, wherein the modulator material is a non-linear optical material.
- 22 129. A method for fabricating a whispering-gallery-mode optical resonator as recited in Claim  
23 121, wherein the modulator material is a semiconductor material.
- 24 130. A method for fabricating a whispering-gallery-mode optical resonator as recited in Claim  
25 120, wherein the modulator-providing step comprises the steps of:  
26 truncating one of the adjacent fiber segments, thereby creating a fiber end-face sufficiently  
27 close to the resonator fiber segment so that at least a portion of the fiber end-face lies  
28 within the whispering-gallery-mode optical wave substantially confined by the resonator  
29 fiber segment; and  
30 depositing a modulator material on at least a portion of the fiber end-face that lies within the  
31 whispering-gallery-mode optical wave.

- 1 131. A method for fabricating a whispering-gallery-mode optical resonator as recited in Claim  
2 130, wherein the modulator material enables modification of optical properties of the  
3 whispering-gallery-mode resonator.
- 4 132. A method for fabricating a whispering-gallery-mode optical resonator as recited in Claim  
5 130, wherein the modulator material enables controlled modulation of optical loss of the  
6 whispering-gallery-mode resonator.
- 7 133. A method for fabricating a whispering-gallery-mode optical resonator as recited in Claim  
8 130, wherein the modulator material enables controlled modulation of optical coupling to the  
9 whispering-gallery-mode resonator.
- 10 134. A method for fabricating a whispering-gallery-mode optical resonator as recited in Claim  
11 130, wherein the modulator material enables controlled modulation of a resonant frequency  
12 of the whispering-gallery-mode resonator.
- 13 135. A method for fabricating a whispering-gallery-mode optical resonator as recited in Claim  
14 130, wherein the modulator material is an electro-optic material.
- 15 136. A method for fabricating a whispering-gallery-mode optical resonator as recited in Claim  
16 130, wherein the modulator material is an electro-absorptive material.
- 17 137. A method for fabricating a whispering-gallery-mode optical resonator as recited in Claim  
18 130, wherein the modulator material is a non-linear optical material.
- 19 138. A method for fabricating a whispering-gallery-mode optical resonator as recited in Claim  
20 130, wherein the modulator material is a semiconductor material.
- 21 139. A whispering-gallery-mode optical resonator fabricated according to the method of any of  
22 Claims 1 through 138.
- 23 140. A whispering-gallery-mode optical resonator, comprising an optical fiber having a spatial  
24 differential of a physical property of the optical fiber between a transverse resonator segment  
25 of the optical fiber and longitudinally adjacent transverse segments of the optical fiber,  
26 thereby enabling substantial confinement by the resonator fiber segment of a substantially  
27 resonant whispering-gallery-mode optical wave propagating around the circumference of the  
28 fiber at least partially within the resonator fiber segment.
- 29 141. A whispering-gallery-mode optical resonator as recited in Claim 140, further incorporating  
30 the limitations of any of Claims 2 through 138.
- 31 142. A method for fabricating a resonant optical power control device, comprising the steps of:

1 positioning a transmission optical fiber within a fiber-alignment groove of an alignment  
2 device;  
3 securing the transmission optical fiber within the fiber-alignment groove of an alignment  
4 device;  
5 positioning a whispering-gallery-mode optical resonator within a resonator-alignment groove  
6 of the alignment device; and  
7 securing the whispering-gallery-mode optical resonator within the resonator-alignment  
8 groove of the alignment device,  
9 wherein:  
10 the whispering-gallery-mode optical resonator comprises an optical fiber having a spatial  
11 differential of a physical property of the optical fiber between a transverse resonator  
12 segment of the optical fiber and longitudinally adjacent transverse segments of the optical  
13 fiber, thereby enabling substantial confinement by the resonator fiber segment of a  
14 substantially resonant whispering-gallery-mode optical wave propagating around the  
15 circumference of the fiber at least partially within the resonator fiber segment;  
16 the alignment device comprises a first alignment substrate, and the fiber-alignment groove  
17 and the resonator-alignment groove are provided on a first surface of the first alignment  
18 substrate; and  
19 the fiber-alignment groove and the resonator-alignment groove of the alignment device  
20 position the resonator fiber segment in substantial tangential engagement with the  
21 transmission optical fiber, thereby optically coupling the resonator fiber segment and the  
22 transmission optical fiber.

23 143. A method for fabricating a resonant optical power control device as recited in Claim 142,  
24 wherein the resonator-alignment groove and the fiber-alignment groove are substantially  
25 perpendicular, and differ in depth so that the transmission fiber is in contact with the  
26 circumference of the resonator fiber segment when the transmission fiber and resonator fiber  
27 segment are positioned within the fiber-alignment groove and the resonator-alignment  
28 groove, respectively.

29 144. A method for fabricating a resonant optical power control device as recited in Claim 143,  
30 further comprising the step of sealing the alignment device, thereby isolating the transmission  
31 fiber and the resonator fiber segment from a use environment.



- 1 145. A method for fabricating a resonant optical power control device as recited in Claim 142,  
2 wherein at least one of the adjacent fiber segments is provided with an alignment structure  
3 and the resonator-alignment groove is provided with a corresponding alignment structure,  
4 thereby enabling reproducible optical coupling of the whispering-gallery-mode optical  
5 resonator and the transmission fiber when the alignment structure of the adjacent fiber  
6 segment and the corresponding alignment structure of the resonator-alignment groove are  
7 engaged.
- 8 146. A method for fabricating a resonant optical power control device as recited in Claim 145,  
9 wherein the alignment structure of the of the adjacent fiber segment comprises a substantially  
10 annular circumferential flange, and the corresponding alignment structure of the resonator-  
11 alignment groove comprises a transverse groove for receiving the flange.
- 12 147. A method for fabricating a resonant optical power control device as recited in Claim 145,  
13 wherein the corresponding alignment structure of the resonator-alignment groove comprises  
14 an inwardly-protruding transverse flange, and the alignment structure of the adjacent fiber  
15 segment comprises a substantially circumferential groove for receiving the flange.
- 16 148. A method for fabricating a resonant optical power control device as recited in Claim 142,  
17 wherein the transmission optical fiber has a substantially D-shaped cross-section with a core  
18 substantially near a flat portion of the D-shaped cross-section, and the flat portion of the D-  
19 shaped cross-section is substantially tangentially aligned with and optically coupled to the  
20 resonator fiber segment.
- 21 149. A method for fabricating a resonant optical power control device as recited in Claim 142,  
22 wherein the transmission optical fiber has a tapered fiber segment and the tapered fiber  
23 segment is substantially tangentially aligned with and optically coupled to the resonator fiber  
24 segment.
- 25 150. A method for fabricating a resonant optical power control device as recited in Claim 149,  
26 wherein the transmission-fiber-positioning step comprises the steps of:  
27 positioning a non-tapered optical fiber in the fiber-alignment groove;  
28 heating a central portion of the non-tapered fiber that crosses the resonator-alignment  
29 groove; and  
30 pulling each end of the non-tapered fiber during the heating step, thereby producing the  
31 transmission fiber in the fiber-alignment groove.

- 1 151. A method for fabricating a resonant optical power control device as recited in Claim 150,  
2 wherein a central portion of the fiber-alignment groove that crosses the resonator-alignment  
3 groove is substantially wider and substantially deeper than end portions of the fiber-alignment  
4 groove, thereby reducing contact between the alignment substrate and the central portion of  
5 the non-tapered optical fiber.
- 6 152. A method for fabricating a resonant optical power control device as recited in Claim 142,  
7 wherein the whispering-gallery-mode resonator is provided with a modulator for controlling  
8 optical properties of the whispering-gallery-mode resonator, and the alignment device is  
9 provided with a modulator control element.
- 10 153. A method for fabricating a resonant optical power control device as recited in Claim 152,  
11 wherein the modulator control element enables application of electronic signals to the  
12 modulator for controlled modulation of the optical properties of the whispering-gallery-mode  
13 resonator.
- 14 154. A method for fabricating a resonant optical power control device as recited in Claim 152,  
15 wherein the modulator control element enables application of optical signals to the modulator  
16 for controlled modulation of the optical properties of the whispering-gallery-mode resonator.
- 17 155. A method for fabricating a resonant optical power control device as recited in Claim 152,  
18 further comprising the step of positioning a secondary optical assembly on the alignment  
19 device in substantial tangential engagement with the resonator fiber segment, thereby  
20 optically coupling the resonator fiber segment and the secondary optical assembly and  
21 enabling controlled modulation of optical coupling of the resonator fiber segment and the  
22 secondary optical assembly through the controlled modulation of the optical properties of the  
23 whispering-gallery-mode resonator.
- 24 156. A method for fabricating a resonant optical power control device as recited in Claim 155,  
25 wherein the secondary optical assembly comprises a second optical transmission fiber.
- 26 157. A method for fabricating a resonant optical power control device as recited in Claim 155,  
27 wherein the secondary optical assembly comprises a second whispering-gallery-mode optical  
28 resonator.
- 29 158. A method for fabricating a resonant optical power control device as recited in Claim 155,  
30 further comprising the step of sealing the alignment device, thereby isolating the transmission

1 fiber, resonator fiber segment, modulator, and secondary optical assembly from a use  
2 environment.

3 159. A method for fabricating a resonant optical power control device as recited in Claim 152,  
4 further comprising the step of sealing the alignment device, thereby isolating the transmission  
5 fiber, resonator fiber segment, and modulator from a use environment.

6 160. A method for fabricating a resonant optical power control device as recited in Claim 142,  
7 further comprising the steps of:  
8 positioning a modulator optical assembly on the alignment device in substantial tangential  
9 engagement with the resonator fiber segment, thereby optically coupling the resonator  
10 fiber segment and the modulator optical assembly and enabling controlled modulation of  
11 optical coupling of the resonator fiber segment and the modulator optical assembly  
12 through the controlled modulation of the optical properties of the modulator optical  
13 assembly;  
14 securing the modulator optical assembly on the alignment device.

15 161. A method for fabricating a resonant optical power control device as recited in Claim 160,  
16 wherein the alignment device comprises a second alignment substrate having the modulator  
17 optical assembly secured thereto and adapted to enable reproducible optical coupling of the  
18 resonator fiber segment and the modulator optical assembly.

19 162. A method for fabricating a resonant optical power control device as recited in Claim 161,  
20 further comprising sealing the second alignment substrate onto the first alignment substrate,  
21 thereby isolating the transmission fiber, resonator fiber segment, and modulator optical  
22 assembly from a use environment.

23 163. A method for fabricating a resonant optical power control device as recited in Claim 160,  
24 wherein the alignment device is provided with a modulator control element for controlled  
25 modulation of the optical properties of the modulator optical assembly.

26 164. A method for fabricating a resonant optical power control device as recited in Claim 163,  
27 wherein the modulator control element enables application of electronic signals to the  
28 modulator optical assembly for controlled modulation of the optical properties of the  
29 modulator optical assembly.

30 165. A method for fabricating a resonant optical power control device as recited in Claim 163,  
31 wherein the modulator control element enables application of optical signals to the modulator

1 optical assembly for controlled modulation of the optical properties of the modulator optical  
2 assembly.

3 166. A method for fabricating a resonant optical power control device as recited in Claim 160,  
4 wherein the modulator optical assembly comprises an optical loss modulator.

5 167. A method for fabricating a resonant optical power control device as recited in Claim 160,  
6 wherein the modulator optical assembly comprises a non-linear optical device.

7 168. A method for fabricating a resonant optical power control device as recited in Claim 160,  
8 wherein the modulator optical assembly comprises an electro-optic device.

9 169. A method for fabricating a resonant optical power control device as recited in Claim 160,  
10 wherein the modulator optical assembly comprises an electro-absorptive device.

11 170. A method for fabricating a resonant optical power control device as recited in Claim 160,  
12 wherein the modulator optical assembly comprises a semiconductor device.

13 171. A method for fabricating a resonant optical power control device as recited in Claim 160,  
14 wherein the modulator optical assembly comprises a second whispering-gallery-mode optical  
15 resonator.

16 172. A method for fabricating a resonant optical power control device as recited in Claim 160,  
17 wherein the modulator optical assembly comprises a second transmission fiber.

18 173. A resonant optical power control device fabricated according to the method of any of Claims  
19 142 through 172.

20 174. A resonant optical power control device, comprising:

21 an alignment device comprising a first alignment substrate having a fiber-alignment groove  
22 and a resonator-alignment groove on a first surface thereof;

23 a transmission fiber secured within the fiber-alignment groove;

24 a whispering-gallery-mode optical resonator secured within the resonator-alignment groove,  
25 the whispering-gallery-mode resonator comprising an optical fiber having a spatial  
26 differential of a physical property of the optical fiber between a transverse resonator  
27 segment of the optical fiber and longitudinally adjacent transverse segments of the optical  
28 fiber, thereby enabling substantial confinement by the resonator fiber segment of a  
29 substantially resonant whispering-gallery-mode optical wave propagating around the  
30 circumference of the fiber at least partially within the resonator fiber segment,

- 1 wherein the fiber-alignment groove and the resonator-alignment groove of the alignment device
- 2 position the resonator fiber segment in substantial tangential engagement with the
- 3 transmission fiber, thereby optically coupling the resonator fiber segment and the transmission
- 4 fiber.
- 5 175. A resonant optical power control device as recited in Claim 174, further incorporating the
- 6 limitations of any of Claims 143 through 172.